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CONTENTS

GENERAL QUESTIONS

Rathkeen L. S. Synchrotron & Neutron Researching
of Nanosystems 3

NANOTECHNOLOGY AND SCANNING PROBE MICROSCOPY

Aleksandrov P. A., Budaragin V. V., Guk V. I., Litvinov V. L. On Fault
Tolerance of Nanoelectronic Integrated Circuits at Irradiation. 7

Vorobjova A. I., Prischepa S. L., Utkina E. A., Komar O. M. Formation
and Properties of Nickel Nanopillars in Porous Aluminum Oxide 15

MODELLING AND DESIGNING OF MNST

**Sapogin V. G., Prokopenko N. N., Marchuk V. I., Manzhula V. G.,
Budyakov A. S.** Inductive Properties of Microscopic Conducting Ring
with Density of Rotational Current of Azimuth Direction. 22

**SCIENCE OF MATERIALS AND TECHNOLOGICAL BASICS
OF MNST**

Dibirova K. S., Kozlov G. V., Magomedov G. M. The Influence
of Crystalline Morphology on Fractal Space Formation for
Nanocomposites Polymer/Organoclay. 27

Volokhov I. V. Study of Technologies for Producing Multilayer
Heterostructures Using Different Methods Vacuum Deposition of
Insulating Coatings on the Hull of the Sensor Elements, Transforming
Equipment for Aerospace Engineering. 30

**Amelichev V. V., Blagov E. V., Kostyuk D. V., Vasilyev D. V.,
Belyakov P. A., Orlov E. P., Abanin I. E., Takhov V. S.,
Rukovishnikov A. I., Rossukanyy N. M.** Magnetoresistive Conrol
Microsystem of Current and Current Fluctuations 39

Eroshkin P. A., Sheshin E. P. Electron Gun with Field Emission
Cathode for Vacuum Tubes 42

Mukhurov N. I., Efremov G. I., Zhvavyi S. P. Electrostatic Micro
Switches. Part 3. Closing-Shutdown Micro Switches 45

MICRO- AND NANOSYSTEM TECHNIQUE ELEMENTS

**Sinev I. V., Smirnov A. V., Grebennikov A. I., Syakina S. D.,
Simakov V. V., Kisin V. V.** Influence of Temperature Pretreatment
to Recognition Ability of Multisensory Microsystems 52